PATENT APPLICATION

684.2728

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TOMOHARU HASE	: Examiner: E. Jones)
Appln. No.: 09/145,982	: Group Art Unit: 2851
Filed: September 3, 1998	;
For: EXPOSURE APPARATUS AND DEVICE MANUFACTURING METHOD INCLUDING GAS PURGING OF A SPACE CONTAINING OPTICAL COMPONENTS	September 13, 1999 : (Monday)) RECEIVE
The Assistant Commissioner for Washington, D.C. 20231	Patents Patents

PETITION UNDER 37 CFR 1.136(a)

Sir:

Applicant petitions the Assistant Commissioner for Patents to extend the time for response to the Office Action dated May 12, 1999 for one month from August 12, 1999 to Monday, September 13, 1999.

Submitted herewith is a check for \$110.00 to cover the fee for the extension under 37 CFR 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205. A duplicate of this petition is enclosed.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010.

110.00 0P

All correspondence should be directed to our address listed below.

Respectfully submitted,

Attorney for Applicant Registration No. 33,326

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